



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 16, 2025	
IGI Report Number	LG705549872
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	7.89 X 5.34 X 3.63 MM

GRADING RESULTS

Carat Weight	1.34 CARAT
Color Grade	D
Clarity Grade	VS 1

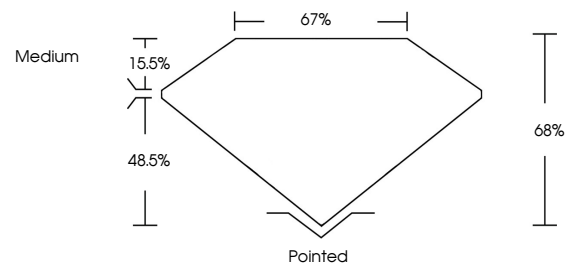
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG705549872

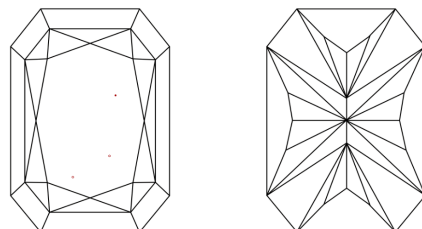
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG705549872
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

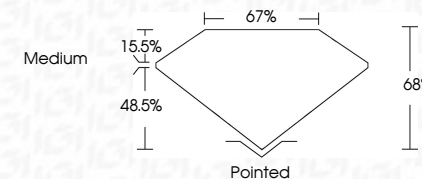
CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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May 16, 2025	
G1 Report No. L	
CUT CORNERED	
7.99 X 5.34 X 3.3	
Carat Weight	
Color Grade	
Clarity Grade	
Depth	
Table	
Girdle	
Culet	
Polish	
Symmetry	
Fluorescence	
Observations(s)	

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.



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